



**REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800**

Attorney Docket No. 051876P352

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of:

Byung-Seop Hong

Serial No. 10/648,183

Filed: August 25, 2003

For: **METHOD FOR RELEASING STRESS
DURING SEMICONDUCTOR DEVICE
FABRICATION**

Examiner: Trung Q. Dang

Art Unit: 2823

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*Entered
PCL
6-20-05
Amended
6-30-05*

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Sir:

In response to the Final Office Action mailed February 24, 2005, regarding the above-referenced application, Applicant respectfully requests entry of the amendment set forth below in consideration of the remarks that follow.